

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Express Mail No.: EL627426116US

In re Application of: RYHANEN et al.

FILING DATE: Herewith

ART UNIT:

TITLE: METHOD AND ARRANGEMENT FOR CONTROLLING
MICROMECHANICAL ELEMENT

ATTORNEY DOCKET NO : 297-010255-US(PAR)

The Commissioner of Patents and Trademarks

Washington, D.C. 20231

PRELIMINARY AMENDMENT

Dear Sir

Please amend the above-identified, enclosed patent application as follows.

IN THE CLAIMS

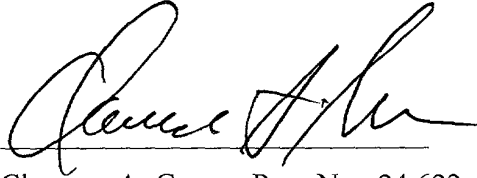
Please amend Claim 40 as rewritten below:

40. An arrangement according to claim 38, **characterized** in that the control electrodes are at least partly covered by a dielectric layer to prevent a galvanic contact between said control electrodes and the micromechanical element.

REMARKS

In accordance with 37 C.F.R. §1.121 (as amended on 11/7/2000) the rewritten claim(s) above are shown on separate page(s) marked up to show all the changes relative to the previous version of that section.

Respectfully submitted,



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Date

Application entitled: METHOD AND ARRANGEMENT FOR CONTROLLING
MICROMECHANICAL ELEMENT

MARKED UP CLAIM(S)

40. An arrangement according to claim 38 or 39, **characterized** in that the control electrodes are at least partly covered by a dielectric layer to prevent a galvanic contact between said control electrodes and the micromechanical element.

40. An arrangement according to claim 38 or 39, characterized in that the control electrodes are at least partly covered by a dielectric layer to prevent a galvanic contact between said control electrodes and the micromechanical element.